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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

TOSHIYUKI TAKIZAWA

Serial No. 10/790,864

Filed: March 3, 2004

Office of Initial Patent  
Examination's Filing Receipt  
Corrections

Title: P-type semiconductor and semiconductor  
hetero material and manufacturing methods thereof

**REQUEST FOR CORRECTED FILING RECEIPT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Enclosed herewith is a copy of the Official Filing Receipt for the above-identified application marked in red indicating corrections to be made thereto.

Accordingly, it is requested that the PTO issue a Corrected Filing Receipt reflecting these corrections.

Respectfully submitted,

TOSHIYUKI TAKIZAWA

By

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June 18, 2004



## UNITED STATES PATENT AND TRADEMARK OFFICE

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APPL NO.	FILING OR 371 (c) DATE	ART UNIT	FIL FEE REC'D	ATTY.DOCKET NO	DRAWINGS	TOT CLMS	IND CLMS
10/790,864	03/03/2004	2811	1950	2004_0347A	14	76	5

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WASHINGTON, DC 20006-1021

CONFIRMATION NO. 3118

## FILING RECEIPT



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Date Mailed: 05/25/2004

Receipt is acknowledged of this regular Patent Application. It will be considered in its order and you will be notified as to the results of the examination. Be sure to provide the U.S. APPLICATION NUMBER, FILING DATE, NAME OF APPLICANT, and TITLE OF INVENTION when inquiring about this application. Fees transmitted by check or draft are subject to collection. Please verify the accuracy of the data presented on this receipt. If an error is noted on this Filing Receipt, please write to the Office of Initial Patent Examination's Filing Receipt Corrections, facsimile number 703-746-9195. Please provide a copy of this Filing Receipt with the changes noted thereon. If you received a "Notice to File Missing Parts" for this application, please submit any corrections to this Filing Receipt with your reply to the Notice. When the USPTO processes the reply to the Notice, the USPTO will generate another Filing Receipt incorporating the requested corrections (if appropriate).

## Applicant(s)

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MAY 26 2004  
WENDEROTH, LIND & PONACK

## Domestic Priority data as claimed by applicant

## Foreign Applications

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JAPAN 2003-306459 08/29/2003

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Non-Publication Request: No

Early Publication Request: No

## Title

P-type semiconductor and semiconductor ~~metro~~ material and manufacturing methods thereof

HETERO

Preliminary Class